Electronic Patent Application Fee Transmittal

Application Number:	10685251
Filing Date:	14-Oct-2003
Title of Invention:	Process for producing low defect density silicon
First Named Inventor:	Robert J. Falster
Filer:	Richard A. Schuth
Attorney Docket Number:	MEMC 96-0056 (2101.3)

Filed as Large Entity

Utility Filing Fees

Description	Fee Code	Quantity	Amount	Sub-Total in USD($)
Basic Filing:				
Pages:				
Claims:				
Miscellaneous-Filing:				
Petition:				
Petition fee- 37 CFR 1.17(g) (Group II)	1463	1	200	200
Patent-Appeals-and-Interference:				
Post-Allowance-and-Post-Issuance:				
Extension-of-Time:				

Description	Fee Code	Quantity	Amount	Sub-Total in USD($)
Miscellaneous:				
			Total in USD ($)	**200**